Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	(thermal near oxide near optical near buffer near material) and (substrate) and (amorphous near silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:47
L2	0	(thermal near oxide near optical near buffer near material) and (amorphous near silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:47
L3	58824	(amorphous near silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:47
L4	9134	(amorphous near silicon) and (mold$4 or seal$4) and (substrate)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:48
L5	9134	(amorphous near silicon) and (mold$4 or seal$4) and (substrate) and (amorphous near silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:49
L6	361	(amorphous near silicon) and (mold$4 or seal$4) and (substrate) and (thermal near oxide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:49
L7	2	(amorphous near silicon) and (mold$4 or seal$4) and (substrate) and (thermal near oxide) and (buffer near material)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:51
L8	0	(amorphous near silicon) and (mold$4 or seal$4) and (substrate) and (thermal near oxide) and (buffer near material) and (optical near waveguide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:52
L9	6	(amorphous near silicon) and (mold$4 or seal$4) and (substrate) and (thermal near oxide) and (optical near waveguide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:55
L10	103	((planar near waveguide) same (substrate)).clm.	US-PGPUB	OR	ON	2005/09/07 09:57

L11	0	((micro near hermatic near cavity) same (waveguide near substrate)).clm.	US-PGPUB	OR	ON	2005/09/07 09:58
L12	0	(micro near hermatic near cavity).clm.	US-PGPUB	OR	ON	2005/09/07 09:58
L13	2	(planar near transmission near optical near waveguide).clm.	US-PGPUB	OR	ON	2005/09/07 09:59
L14	0	(walls near3 micro near hermatic near cavity).clm.	US-PGPUB	OR	ON	2005/09/07 10:00
L15	2	10 and 13	US-PGPUB	OR	ON	2005/09/07 10:00

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	0	(thermal near oxide near optical near buffer near material) and (substrate) and (amorphous near silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:47
L2	0	(thermal near oxide near optical near buffer near material) and (amorphous near silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:47
L3	58824	(amorphous near silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:47
L4	9134	(amorphous near silicon) and (mold$4 or seal$4) and (substrate)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:48
L5	9134	(amorphous near silicon) and (mold$4 or seal$4) and (substrate) and (amorphous near silicon)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:49
L6	361	(amorphous near silicon) and (mold$4 or seal$4) and (substrate) and (thermal near oxide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:49
L7	2	(amorphous near silicon) and (mold$4 or seal$4) and (substrate) and (thermal near oxide) and (buffer near material)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:51
L8	0	(amorphous near silicon) and (mold$4 or seal$4) and (substrate) and (thermal near oxide) and (buffer near material) and (optical near waveguide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:52
L9	6	(amorphous near silicon) and (mold$4 or seal$4) and (substrate) and (thermal near oxide) and (optical near waveguide)	US-PGPUB; USPAT; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/09/07 09:52